

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	18031	((semiconductor or wafer or substrate) near epitaxial)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 14:09
L2	10	((semiconductor or wafer or substrate) near epitaxial) and "FET" and "InGaP" and "n-type" and temperature and mobility and electron and space\$3 and channel and "MOCVD"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/01/20 14:11